IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Applicants/ Petitioners	: Lin et al.
Application No.	: 10/710,843
For	: A METHOD OF MANUFACTURING SEMICONDUCTOR LASER DEVICE STRUCTURE
Notice of Allowance Mailed	: November 30, 2007
Art Unit	: 2823
Examiner	: LEE, JAE

RENEWED PETITION TO WITHDRAW HOLDING OF ABANDONMENT AND REVIVE APPLICATION UNDER 37 CFR 1.181
(Total Pages: 2+1)

U.S. Patent and Trademark Office
ATTN: Office of Petitions
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Mail Stop **Petition**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Dear Sir,

In response to the dismissed Decision of Petition mailed on June 20, 2008, Applicants/Petitioners hereby request for reconsideration of the said decision by submitting this request accompanying with the follows.

1. Issue Fee Transmittal (PTOL-85B) in 1 page.

Assignee which Applicants/Petitioners have assigned their interests of the above-referenced application to is entitled to a status as **Small Entity.** The commissioner is authorized to charge the following required fees and any fees required in connection with filing this paper to Deposit Account **50-2620** (Order No. 13063-US-PA).

1. Petition Fee under 37 CFR 1.17(m) for Petition to revive unintentionally abandoned application in an amount of USD$ 770.

2. Utility Issue Fee of USD$ 720 and Publication fee of USD$ 300 under 37 CFR 1.18(a) and 1.18(d).

Thank you for your attention and assistance in this regard. Should you need any further information, please feel free to contact the undersigned.

Respectfully Submitted,
JIANQ CHYUN Intellectual Property Office

Date: July 17, 2008   By: _Belinda Lee_

Belinda Lee
Registration No.: 46,863

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